



CIPW

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant: Shin Seung Park

) I hereby certify that this paper is being  
deposited with the United States Postal  
Service with sufficient postage as first  
class mail in an envelope addressed to  
Commissioner for Patents, P.O. Box  
1450, Alexandria, Virginia 22313-  
1450, on October 19, 2005.

Serial No.: 10/735,228

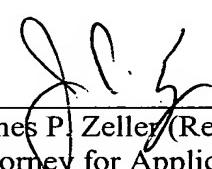
Filed: December 12, 2003

Title: METHOD OF FORMING  
METAL LINE OF  
SEMICONDUCTOR  
DEVICE

Group Art Unit: 1765

Examiner: To be assigned

Attorney Docket No.: 29936/39847

  
\_\_\_\_\_  
James P. Zeller (Reg. No. 28,491)  
Attorney for Applicants

**AMENDMENT "A"**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend this application as follows:

the amendments to the claims section begins on page 2 of this paper;

the remarks section begins on page 4 of this paper.